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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of)
Koji OKAMOTO)
Serial No. 10/046,753) Group Art Unit: 3627
Filed: January 17, 2002) Examiner: Rena Dye

For: SUPPLY SYSTEM OF COMPOUND FOR CHEMICAL VAPOR
DEPOSITION AND THIN-FILM MANUFACTURING SYSTEM
HAVING THE SAME COMPOUND SUPPLY SYSTEM

INFORMATION DISCLOSURE STATEMENT

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Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

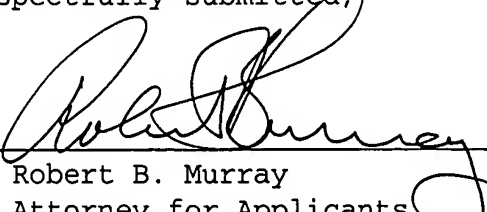
Dear Sir:

Under the provisions of 37 C.F.R. §§ 1.56, 1.97 and 1.98,
Applicant submits herewith copies of publications that the Office
may wish to consider in examination of the subject application.
The publications are listed on the attached form PTO-1449.

This paper is being submitted before the receipt of an
Official Action on the merits of the present application.

Respectfully submitted,

By


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¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code. ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language translation is attached. AB indicates that only an English language abstract is attached.